

**PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE CITATION**
(Use several sheets if necessary)

Sheet 1 of 1

~~7784-000425DVA~~

10/717,354

APPLICANT

Minas H. Tanielian

FILING DATE

November 19, 2003

GROUP **3729**

~~Not Yet Assigned~~

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.		5,632,841	5/27/1997	Hellbaum et al.	—	
2.		5,849,125	12/15/1998	Clark	—	
3.		6,162,313	12/19/2000	Bansemir et al.	—	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.	<i>IN</i>	2001 Face International Corporation, "Thunder White Paper", February 21, 2001, Pgs 1-10

Examiner:

Minas H. Tanielian

Date Considered:

2/22/05

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM HDP-1449 (Based on Form PTO-1449) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Sheet 1 of 2	ATTORNEY DOCKET NO.	SERIAL NO. <u>10/717,354</u>
	7784-000425DVA	Not Yet Assigned
	APPLICANT	
	Minas H. Tanielian	
	FILING DATE	GROUP <u>3729</u>
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U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.	<u>TN</u>	3,456,134	7/15/1969	Ko	_____	
2.		3,466,473	9/9/1969	Rhoten	_____	
3.		3,553,588	1/5/1971	W. Honig	_____	
4.		3,624,451	11/30/1971	Gauld, et al.	_____	
5.		4,467,236	8/21/1984	Kolm et al.	_____	
6.		4,510,484	4/9/1985	Snyder	_____	
7.		5,463,374	10/31/1995	Mendez et al.	_____	
8.		5,751,091	5/12/1998	Takahashi	_____	
9.		5,801,475	9/1/1998	Kimura	_____	
10.		6,306,773	10/23/2001	Adas et al.	_____	
11.		6,382,026 B1	5/7/2002	Tajika et al.	_____	
12.		6,407,484	5/12/1998	Takahashi	_____	
13.	<u>TN</u>	6,530,276 B2	3/11/2003	Tajika et al.	_____	

FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes No
1.	<u>TN</u>	2 026 284	7/17/1979	UK	_____	
2.	<u>TN</u>	2 064 883	11/25/1980	UK	_____	

Examiner: <u>Tan Nguyen</u>	Date Considered: <u>2/22/05</u>
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<p>FORM HDP-1449 (Based on Form PTO-1449)</p> <p>PATENT AND TRADEMARK OFFICE</p> <p>INFORMATION DISCLOSURE CITATION</p> <p>(Use several sheets if necessary)</p> <p>Sheet 2 of 2</p>	ATTORNEY DOCKET NO.	SERIAL NO. <u>10/717,354</u>
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	Minas H. Tanielian	
	FILING DATE	GROUP <u>3729</u>
Herewith	Not Yet Assigned	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.	<u>TN</u>	F. J. von Preissig and E.S. Kim, Topics in Finite-Element Modeling of Piezoelectric MEMS.
2.		Ibong Jung and Yongrae Roh, Design and fabrication of piezoceramic biomorph vibration sensors, Sensors and Actuators A 69 (1998) pp. 259-266.
3.		John Kymissis, Clyde Kendall, Joseph Paradiso, Neil Gershenfeld, "Parasitic Power Harvesting in Shoes", 8/1998, p. 1-8.
4.		Kloeppe, James E., Residual stress in piezoelectric ceramics can be reduced, put to work, News Bureau, (Sept. 1, 2000).
5.	<u>TN</u>	Meteer, Jami, Front-Side Processing of a Piezoelectric MEMS Accelerometer, The Pennsylvania State University National Nanofabrication Users Network, pp. 48-49.

Examiner: <u><i>Val Tanielian</i></u>	Date Considered: <u>2/22/05</u>
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